

Semiconductor device and method

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Ozawa, Takanori

Arita, Koji et al.

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L	Hits	Search Text	DB	Time stamp
Number	070	(6	исращ	2004/02/21
1	278	(form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)	USPAT	2004/03/21 18:29
2	350	zhang-fengyan.in. hsu-sheng-teng.in.	USPAT;	2004/03/21
		ying-hong.in.	US-PGPUB;	18:22
			EPO; JPO; IBM TDB	
3	277	((form\$4 or creat\$4) adj (passivation adj	USPAT;	2004/03/21
		layer) and (ferroelect\$4 or magnet\$4))	US-PGPUB;	18:22
		not (zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
4	69	<pre>ying-hong.in.) (((form\$4 or creat\$4) adj (passivation</pre>	IBM_TDB USPAT;	2004/03/21
ן יי	0,5	adj layer) and (ferroelect\$4 or	US-PGPUB;	18:24
		magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	
		hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and	IBM_TDB	
		(chamber) and (aluminum of Al) and (titanium or "Ti")		
5	2	((((form\$4 or creat\$4) adj (passivation	USPAT;	2004/03/21
'		adj layer) and (ferroelect\$4 or	US-PGPUB;	18:29
		magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and	EPO; JPO; IBM TDB	
		(chamber) and (aluminum or "Al") and	1201_100	
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
6	67	oxide) or "Al.sub.20.sub.3")) ((((form\$4 or creat\$4) adj (passivation	USPAT;	2004/03/21
		adj layer) and (ferroelect\$4 or	US-PGPUB;	18:29
		magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	
		hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and	IBM_TDB	
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or "TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))		
7	0	(((((form\$4 or creat\$4) adj (passivation	USPAT	2004/03/21
		adj layer) and (ferroelect\$4 or		18:30
		<pre>magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and</pre>		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or "Ti")) and (((titanium adj oxide) or	1	
		"TiO.sub.2") and ((citanium ad) oxide) or		
		"Al.sub.20.sub.3")))) and ((form\$4 or		
	_	creat\$4) adj (passivation adj layer)).ti.	USPAT	2004/03/21
8	0	(((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or	OSPAT	18:30
		magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and (titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not	[
		(zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or	1	
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3"))) and ((form\$4 or creat\$4) adj (passivation adj layer)).ab.		
	<u> </u>	Oldery day (passivation day lajol//.ds.		<u> </u>

9	6	(((((form\$4 or creat\$4) adj (passivation	USPAT	2004/03/21
	ľ	adj layer) and (ferroelect\$4 or		19:05
		magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
,		ving-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) and ((form\$4 or		
		creat\$4) adj (passivation adj		
		layer)).clm.		0004/03/01
10	61	1 1 1 1 1 2 1 2 1 2	USPAT;	2004/03/21
		adj layer) and (ferroelect\$4 or	US-PGPUB;	19:06
		magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	
		hsu-sheng-teng.in. ying-hong.in.)) and	IBM_TDB	
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		'
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) not (((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) and		}
		((form\$4 or creat\$4) adj (passivation adj		
		laver)).clm.)	l	1

11	0	(((((form\$4 or creat\$4) adj (passivation	USPAT;	2004/03/21
11	U	adj layer) and (ferroelect\$4 or	US-PGPUB;	19:06
				19.00
		magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	
		hsu-sheng-teng.in. ying-hong.in.)) and	IBM_TDB	
		(chamber) and (aluminum or "Al") and		
-		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) not (((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
1		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not ((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		/-hamban\ and /aluminum an "hl"\ and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) and		
		((form\$4 or creat\$4) adj (passivation adj		
ļ		layer)).clm.)) and (passivation).ti.		
12	6	(((((form\$4 or creat\$4) adj (passivation	USPAT;	2004/03/21
		adj layer) and (ferroelect\$4 or	US-PGPUB;	19:12
		magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	İ
		hsu-sheng-teng.in. ying-hong.in.)) and	IBM TDB	
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
1		creat\$4) adj (passivation adj layer) and		
		(famusalast) and (passivation and layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
l		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
İ		"TiO.sub.2") and ((aluminum adj oxide) or		
1		"Al.sub.20.sub.3")))) not (((((form\$4 or		
1		creat\$4) adj (passivation adj layer) and	1	
		(ferroelect\$4 or magnet\$4)) not	1	
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and	1	
1		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj	1	
		oxide) or "Al.sub.20.sub.3")))) and	1	
j		((form\$4 or creat\$4) adj (passivation adj	1	
		layer)).clm.)) and (passivation).ab.	1	I

13 55	(((((form\$4 or creat\$4) adj (passivation	USPAT;	2004/03/21
	adj layer) and (ferroelect\$4 or	US-PGPUB;	19:12
	magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	
	hsu-sheng-teng.in. ying-hong.in.)) and	IBM_TDB	
	(chamber) and (aluminum or "Al") and	_	
	(titanium or "Ti")) not ((((form\$4 or		
	creat\$4) adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		Ì
	(aluminum or "Al") and (titanium or		1
	"Ti")) and (((titanium adj oxide) or		
	"TiO.sub.2") and ((aluminum adj oxide) or		
	"Al.sub.20.sub.3")))) not (((((form\$4 or		
	creat\$4) adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
	(aluminum or "Al") and (titanium or		
	"Ti")) not (((((form\$4 or creat\$4) adj		
	(passivation adj layer) and (ferroelect\$4		
	or magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
	(titanium or "Ti")) and (((titanium adj		
	oxide) or "TiO.sub.2") and ((aluminum adj		
	oxide) or "Al.sub.20.sub.3")))) and		
	((form\$4 or creat\$4) adj (passivation adj		
	layer)).clm.)) not ((((((form\$4 or		
	creat\$4) adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or		
	"Ti")) not (((((form\$4 or creat\$4) adj		
	(passivation adj layer) and (ferroelect\$4		
	or magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
	(titanium or "Ti")) and (((titanium adj		
	oxide) or "TiO.sub.2") and ((aluminum adj		
	oxide) or "Al.sub.20.sub.3")))) not		
	((((((form\$4 or creat\$4) adj (passivation		
	adj layer) and (ferroelect\$4 or		
	magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
	(titanium or "Ti")) not ((((form\$4 or		
	creat\$4) adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
	(aluminum or "Al") and (titanium or		
	"Ti")) and (((titanium adj oxide) or		
	"TiO.sub.2") and ((aluminum adj oxide) or		
	"Al.sub.20.sub.3")))) and ((form\$4 or		
	creat\$4) adj (passivation adj		
L	layer)).clm.)) and (passivation).ab.)		<u> </u>

6 ((((((form\$4 or creat\$4) adj	USPAT;	2004/03/21
			19:18
		•	
cı	reat\$4) adj (passivation adj layer) and		
(:	zhang-fengyan.in. hsu-sheng-teng.in.		
y:	ing-hong.in.)) and (chamber) and		
(a	aluminum or "Al") and (titanium or		
(1	passivation adj layer) and (ferroelect\$4		
((chamber) and (aluminum or "Al") and		
(1	titanium or "Ti")) and (((titanium adj		
ac	dj layer) and (ferroelect\$4 or		
(0	chamber) and (aluminum or "Al") and		
, ,	2 22		
	reat\$4) adj (passivation adj ayer)).clm.)) and (passivation).ab.))		
		i	1
	((passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) not ((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) and (((titanium adj oxide) or "Tio.sub.2") and ((aluminum adj oxide) or "Al.sub.20.sub.3")))) not ((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) not ((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) and ((titanium adj oxide) or "Tio.sub.2") and ((aluminum adj oxide) or "Tio.sub.1") and ((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and ((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and ((titanium or "Ti")) and ((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in.) hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium adj oxide) or "Tio.sub.2") and ((aluminum adj oxide) or "Tio.sub.2") and ((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in.) hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) and ((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in.) and (chamber) and	(passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) not (((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium adj oxide) or "TiO.sub.2") and ((aluminum adj oxide) or "Al.sub.2o.sub.3"))) not ((((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and (titanium adj oxide) or "TiO.sub.2") and (ferroelect\$4 or magnet\$4)) not (((((form\$4 or creat\$4) adj (passivation adj layer)) and ((titanium adj oxide) or "Al.sub.2o.sub.3"))) and ((form\$4 or creat\$4) adj (passivation adj layer)).clm.)) not ((((((form\$4 or creat\$4) adj (passivation adj layer)).clm.)) not ((((((form\$4 or creat\$4) adj (passivation adj layer)) and ((form\$4 or creat\$4) adj (passivation adj layer)) and ((form\$4 or creat\$4) and (chamber) and (aluminum or "Al") and (titanium or "Ti")) not (((((form\$4 or creat\$4) adj (passivation adj layer)) and (chamber) and (aluminum or "Al") and (titanium adj oxide) or "TiO.sub.2") and ((aluminum adj oxide) or "TiO.sub.2") and ((aluminum adj oxide) or "TiO.sub.2") and ((cluminum adj oxide) or "TiO.sub.2") and ((cluminum adj oxide) or "TiO.sub.2") and ((cluminum adj oxide) or "TiO.sub.2") and ((fluminum adj oxide) or "TiO.sub.2") and ((fluminum adj oxide) or "TiO.sub.2") and ((cluminum adj oxide) or "TiO.sub.2") and (cluminum adj oxide) or "TiO.sub.2") and (cluminum adj oxide) or "TiO.sub.2") and (cluminum or "Al") and (titanium adj oxide) or "TiO.sub.2") and (cluminum or "Ti"))

7.5		111111111111111111111111111111111111111	I II C D T =	10004/02/01
15	49	(((((((form\$4 or creat\$4) adj	USPAT;	2004/03/21
		(passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in.	US-PGPUB; EPO; JPO;	19:18
		hsu-sheng-teng.in. ying-hong.in.)) and	IBM TDB	
		(chamber) and (aluminum or "Al") and	1511_155	
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3"))) not (((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not ((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) and ((form\$4 or creat\$4) adj (passivation adj		
		((form\$4 or creat\$4) adj (passivation adj layer)).clm.)) not (((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
1		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or	:	
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		ļ
		oxide) or "Al.sub.20.sub.3")))) not		
		(((((form\$4 or creat\$4) adj (passivation		
		adj layer) and (ferroelect\$4 or		
		magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
1		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in.		
		(zhang-lengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or	1	
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) and ((form\$4 or		
		creat\$4) adj (passivation adj		
		layer)).clm.)) and (passivation).ab.))		
		not ((((((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		•
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
	1	creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not	1	
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or "TiO.sub.20.sub.3"))) not (((((form\$4 or	<u></u>	
Search His	tory 3	/creats 1 4dd (passivat on add layer) and		
]	(ferroelect\$4 or magnet\$4)) not		
C:\APPS\E	 AST\Worksp	adabang61ebaganspn. hsu-sheng-teng.in.		
	F (525P	ying-hong.in.)) and (chamber) and	1	1
		•		

16	5	(((((((form\$4 or creat\$4) adj	USPAT;	2004/03/21
		(passivation adj layer) and (ferroelect\$4	US-PGPUB;	19:23
		or magnet\$4)) not (zhang-fengyan.in.	EPO; JPO;	
		hsu-sheng-teng.in. ying-hong.in.)) and	IBM_TDB	
1		(chamber) and (aluminum or "Al") and		1
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
ĺ		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) not (((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
1		or magnet\$4)) not (zhang-fengyan.in.		
1		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and (titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
-		oxide) or "Al.sub.20.sub.3")))) and		
		((form\$4 or creat\$4) adj (passivation adj		
		layer)).clm.)) not (((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
1		(ferroelect\$4 or magnet\$4)) not		
İ		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not (((((form\$4 or creat\$4) adj	1	
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) not		
		(((((form\$4 or creat\$4) adj (passivation		
		adj layer) and (ferroelect\$4 or		
		magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in.		
		(znang-rengyan.in. nsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
		ving-nong.in.;) and (chamber) and (aluminum or "Al") and (titanium or	1	
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) and ((form\$4 or	1	
		creat\$4) adj (passivation adj		
		layer)).clm.)) and (passivation).ab.))	1	
		not (((((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		100
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ving-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		["A] sub 20 sub 3"))) not (((((form\$4 or		
earch Hist	ory 3	Creats4;42df (passivatusn adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
	m\ ** 1	adabang61e8gganspn. hsu-sheng-teng.in.	I	1

17	237	(ferroelectr\$4 or magnet\$4) and	USPAT;	2004/03/21
		(sputter\$4 with passivation)	US-PGPUB;	19:37
		-	EPO; JPO;	
			IBM TDB	
18	16	((ferroelectr\$4 or magnet\$4) and	USPAT;	2004/03/21
+		(sputter\$4 with passivation)) and	US-PGPUB;	19:25
		(((Aluminum or "Al") and (Titanium or	EPO; JPO;	
		"Ti")) with passivation)	IBM TDB	1

19	12	(((ferroelectr\$4 or magnet\$4) and	USPAT;	2004/03/21
		(sputter\$4 with passivation)) and	US-PGPUB;	19:26
		(((Aluminum or "Al") and (Titanium or "Ti")) with passivation)) not	EPO; JPO; IBM TDB	
		((zhang-fengyan.in. hsu-sheng-teng.in.	15.1_155	
		<pre>ying-hong.in.) (((((form\$4 or creat\$4)</pre>		
		adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or	ļ	
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) and		
		((form\$4 or creat\$4) adj (passivation adj		
		<pre>layer)).ab.) (((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4</pre>		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.	·	
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or "Al.sub.20.sub.3"))) and ((form\$4 or		
		creat\$4) adj (passivation adj		
		layer)).clm.) ((((((form\$4 or creat\$4)		
		adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not ((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.	į	
		hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) not		
		((((((form\$4 or creat\$4) adj (passivation		
		<pre>adj layer) and (ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in.</pre>		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not (zhang-fengyan.in. hsu-sheng-teng.in.		
		(zhang-lengyan.in. hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) and ((form\$4 or creat\$4) adj (passivation adj		
		layer)).clm.)) and (passivation).ab.)		
		(((((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and (chamber) and (aluminum or "Al") and		
		(chamber) and (aluminum or "Al") and (titanium or "Ti")) not ((((form\$4 or		
	ļ <u>.</u>	creatS4) adi (nassivation adi laver) and		<u> </u>
earch Hi	story 3	(4ferfoeie2i39 BM magRe9349) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
\APPS\E	AST\Worksp	ageBg1be2g8\$p.wspand (chamber) and (aluminum or "Al") and (titanium or		I

20	170 (ferroelectr\$4 or magnet\$4) and	USPAT; 2004/03/21
	((Aluminum or "Al") and (Titanium or	US-PGPUB; 20:41
	"Ti") with passivation)	EPO; JPO;
		IBM TDB

1	145	((ferroelectr\$4 or magnet\$4) and	USPAT;	2004/03/21
-		((Aluminum or "Al") and (Titanium or	US-PGPUB;	19:38
		"Ti") with passivation)) not	EPO; JPO;	
		((zhang-fengyan.in. hsu-sheng-teng.in.	IBM TDB	
		<pre>ving-hong.in.) (((((form\$4 or creat\$4)</pre>	_	
		adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj	:	
		oxide) or "Al.sub.20.sub.3")))) and		
		((form\$4 or creat\$4) adj (passivation adj		
ŀ		layer)).ab.) (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		-
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or	}	
		"Al.sub.20.sub.3")))) and ((form\$4 or		
		creat\$4) adj (passivation adj		
		layer)).clm.) ((((((form\$4 or creat\$4)		
		adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
1		ving-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or "Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation add layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) not		
		((((((form\$4 or creat\$4) adj (passivation		
		adj layer) and (ferroelect\$4 or		
		magnet\$4)) not (zhang-fengyan.in.		
İ		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
[(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and (ferroelect\$4 or magnet\$4)) not	1	
		, , , , , , , , , , , , , , , , , , ,		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
[(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or		
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3"))) and ((form\$4 or		
		creat\$4) adj (passivation adj		
		layer)).clm.)) and (passivation).ab.)		
		<pre>((((((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4</pre>		
1				
		or magnet\$4)) not (zhang-fengyan.in.		
1		hsu-sheng-teng.in. ying-hong.in.)) and		
1		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and	1	
arch Histo	ory 3	(ferroelects4 or magnets4)) not (zhangefenggan:Mn. hsdgsheng-teng.in.		
	-	\zinang=tengyan.in. nsu=sneng=teng.in.	1	
_	n\ 5.7 \-	ying-hong.in.)) and (chamber) and acakኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒ		
	INWORKSD	acasquwaymgag.waga") and (titanium of "Ti")) and (((titanium adj oxide) or	L	1

22	95 (((ferroelectr\$4 or magnet\$4) and	USPAT;	2004/03/21
	((Aluminum or "Al") and (Titanium or	US-PGPUB;	19:38
	"Ti") with passivation)) not	EPO; JPO;	
	((zhang-fengyan.in. hsu-sheng-teng.in.	IBM TDB	
	<pre>ying-hong.in.) (((((form\$4 or creat\$4)</pre>	_	
	adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		1
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
	(aluminum or "Al") and (titanium or		I.
	"Ti")) not (((((form\$4 or creat\$4) adj		
	(passivation adj layer) and (ferroelect\$4		
	or magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and	1	
	(titanium or "Ti")) and (((titanium adj		
	oxide) or "TiO.sub.2") and ((aluminum adj		
	oxide) or "Al.sub.20.sub.3")))) and		
	((form\$4 or creat\$4) adj (passivation adj		
	layer)).ab.) (((((form\$4 or creat\$4) adj		
	(passivation adj layer) and (ferroelect\$4		
	or magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
1	(titanium or "Ti")) not (((((form\$4 or		
1	creat\$4) adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
	(aluminum or "Al") and (titanium or		
	"Ti")) and (((titanium adj oxide) or		
	"TiO.sub.2") and ((aluminum adj oxide) or		
	"Al.sub.20.sub.3")))) and ((form\$4 or		
	creat\$4) adj (passivation adj		
	layer)).clm.) ((((((form\$4 or creat\$4)		
	adj (passivation adj layer) and		
	(ferroelect\$4 or magnet\$4)) not		
	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
	(aluminum or "Al") and (titanium or		
	"Ti")) not (((((form\$4 or creat\$4) adj		
	(passivation adj layer) and (ferroelect\$4		
	or magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
	(titanium or "Ti")) and (((titanium adj		
	oxide) or "TiO.sub.2") and ((aluminum adj		
	oxide) or "Al.sub.20.sub.3")))) not		
	(((((form\$4 or creat\$4) adj (passivation		
]	adj layer) and (ferroelect\$4 or		
	magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
	(titanium or "Ti")) not ((((form\$4 or		
	creat\$4) adj (passivation adj layer) and		
]	(ferroelect\$4 or magnet\$4)) not		
]	(zhang-fengyan.in. hsu-sheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
	(aluminum or "Al") and (titanium or		
	"Ti")) and (((titanium adj oxide) or		
	"TiO.sub.2") and ((aluminum adj oxide) or		
	"Al.sub.20.sub.3")))) and ((form\$4 or		
	creat\$4) adj (passivation adj		
	layer)).clm.)) and (passivation).ab.)		
	(((((((form\$4 or creat\$4) adj		
	(passivation adj layer) and (ferroelect\$4		
	or magnet\$4)) not (zhang-fengyan.in.		
	hsu-sheng-teng.in. ying-hong.in.)) and		
	(chamber) and (aluminum or "Al") and		
	(titanium or "Ti")) not ((((form\$4 or		
]	creat\$4) adj (passivation adj layer) and		
	(ferroelects4 or magnets4)) not		
Search History	3/21004g8 142 40 PMn. hsdgsheng-teng.in.		
	ying-hong.in.)) and (chamber) and		
C. \ ADDC\ EXCM\ W-	rkspacesኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒ		
C. MEES (EAST (WO	"Ti")) and (((titanium adj oxide) or	l	
	-1 // and //(creatitum ad) oxide/ or		

3	45	((((ferroelectr\$4 or magnet\$4) and	USPAT;	2004/03/21
		((Aluminum or "Al") and (Titanium or	US-PGPUB;	19:39
		"Ti") with passivation)) not	EPO; JPO;	
		((zhang-fengyan.in. hsu-sheng-teng.in.	IBM_TDB	
		<pre>ying-hong.in.) (((((form\$4 or creat\$4) adj (passivation adj layer) and</pre>		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not ((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
l		oxide) or "TiO.sub.2") and ((aluminum adj		
		oxide) or "Al.sub.20.sub.3")))) and		
		((form\$4 or creat\$4) adj (passivation adj		
1		<pre>layer)).ab.) (((((form\$4 or creat\$4) adj (passivation adj layer) and (ferroelect\$4</pre>		
ľ		or magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) and (((titanium adj oxide) or	ļ	
		"TiO.sub.2") and ((aluminum adj oxide) or		
		"Al.sub.20.sub.3")))) and ((form\$4 or		
		creat\$4) adj (passivation adj		
		layer)).clm.) ((((((form\$4 or creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
		"Ti")) not (((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4		
		or magnet\$4)) not (zhang-fengyan.in.	ļ	
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) and (((titanium adj		
		oxide) or "TiO.sub.2") and ((aluminum adj		
İ		oxide) or "Al.sub.20.sub.3")))) not (((((form\$4 or creat\$4) adj (passivation		
		adj layer) and (ferroelect\$4 or		
		magnet\$4)) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
1		(chamber) and (aluminum or "Al") and		
		(titanium or "Ti")) not ((((form\$4 or		
		creat\$4) adj (passivation adj layer) and		
		(ferroelect\$4 or magnet\$4)) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber) and		
		(aluminum or "Al") and (titanium or		
1		"Ti")) and (((titanium adj oxide) or	1	
		"TiO.sub.2") and ((aluminum adj oxide) or "Al.sub.20.sub.3")))) and ((form\$4 or	ĺ	
		creat\$4) adj (passivation adj	1	
		layer)).clm.)) and (passivation).ab.)	1	
		(((((((form\$4 or creat\$4) adj		
		(passivation adj layer) and (ferroelect\$4	1	
		or magnet\$4)) not (zhang-fengyan.in.	1	
		hsu-sheng-teng.in. ying-hong.in.)) and	1	
		(chamber) and (aluminum or "Al") and	1	
		(titanium or "Ti")) not ((((form\$4 or	1	
		creat\$4) adj (passivation adj layer) and	1	
arch His	tory 3	/Al/04 8:42:40 PM Page, 13	 	
1113	JULY J	/ 21/19 fengyan In. hadgsheng-teng.in.	1	
	om\ ** *	ying-hong.in.)) and (chamber) and acelኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒኒ	1	
	STIWORKSD	aceswindanised map.) and (fighton of	1	1

24	2		USPAT;	2004/03/21
		("Al-Ti-O" or "AlTiO")	US-PGPUB;	20:42
			EPO; JPO;	
			IBM_TDB	
-	0	"2001/0034106".PN.	USPĀT	2004/03/21
				18:20
_	0	bhang-fengyan.in.	USPAT;	2004/03/19
	,		US-PGPUB;	17:23
			EPO; JPO;	
			IBM TDB	
_	122	zhang-fengyan.in.	USPAT;	2004/03/19
-	122	Zhang-Tengyan. In.	US-PGPUB;	17:23
			EPO; JPO;	17.23
	200		IBM_TDB	2024/22/12
-	306	hsu-sheng-teng.in.	USPAT;	2004/03/19
			US-PGPUB;	17:23
			EPO; JPO;	
			IBM_TDB	
-	13	ying-hong.in.	USPAT;	2004/03/19
			US-PGPUB;	17:23
1			EPO; JPO;	
		· ·	IBM_TDB	
-	5	(titanium near2 aluminum near2	USPĀT;	2004/03/19
		passivation) and ferroelectric	US-PGPUB;	17:23
		<u></u>	EPO; JPO;	
			IBM TDB	
l _	ا ا	((titanium near2 aluminum near2	USPAT;	2004/03/19
		passivation) and ferroelectric) not	US-PGPUB;	17:23
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	17.25
		ving-hong.in.)	IBM TDB	
			USPAT;	2004/03/19
-	573	((titanium and aluminum and passivation)		1 ' ' 1
		and ferroelectric) not (zhang-fengyan.in.	US-PGPUB;	17:24
		hsu-sheng-teng.in. ying-hong.in.)	EPO; JPO;	
			IBM_TDB	
-	266		USPAT;	2004/03/19
1		and ferroelectric) not (zhang-fengyan.in.	US-PGPUB;	17:24
		hsu-sheng-teng.in. ying-hong.in.)) and	EPO; JPO;	
	•	(chamber and (method or process))	IBM_TDB	
-	87	(((titanium and aluminum and	USPAT;	2004/03/19
		passivation) and ferroelectric) not	US-PGPUB;	17:24
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
İ		ying-hong.in.)) and (chamber and (method	IBM TDB	
	Ì	or process))) and ((top or upper) adj	_==_	
	ł	electrode)		
_	0	(((((titanium and aluminum and	USPAT;	2004/03/19
		passivation) and ferroelectric) not	US-PGPUB;	17:24
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
			IBM TDB	
		ying-hong.in.)) and (chamber and (method	I TEM_TOB	
		or process))) and ((top or upper) adj		
		electrode)) and passivation.ti.) not		
		(((((titanium and aluminum and		
		passivation) and ferroelectric) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber and (method		
		or process))) and ((top or upper) adj		
	1	electrode)) and passivation.ab.)		
-	1	"6630702"	USPAT;	2004/03/19
			US-PGPUB;	17:24
			EPO; JPO;	
			IBM TDB	
-	580	(titanium and aluminum and passivation)	USPAT;	2004/03/19
	300	and ferroelectric	US-PGPUB;	17:24
		41.4 101100100110	EPO; JPO;	
			IBM TDB	
	5	/shang-fonguan in hou-shang-tong in	USPAT;	2004/03/19
_	3	(zhang-fengyan.in. hsu-sheng-teng.in.	US-PGPUB;	17:24
1		ying-hong.in.) and ((titanium near2		11.47
	· '	aluminum near2 passivation))	EPO; JPO;	
1	ĺ		IBM_TDB_	1

-	2	<pre>((((titanium and aluminum and passivation) and ferroelectric) not</pre>	USPAT; US-PGPUB;	2004/03/19 17:24
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
		ying-hong.in.)) and (chamber and (method or process))) and ((top or upper) adj	IBM_TDB	
		electrode)) and passivation.ti.		
_	2	•	USPAT;	2004/03/19
		passivation) and ferroelectric) not	US-PGPUB;	17:30
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
1		ying-hong.in.)) and (chamber and (method	IBM_TDB	
8		or process))) and ((top or upper) adj		
		<pre>electrode)) and passivation.ab.) not (((((titanium and aluminum and</pre>		
		passivation) and ferroelectric) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber and (method		
1		or process))) and ((top or upper) adj		
	411	electrode)) and passivation.ti.)	HCDAT.	2004/02/10
-	411	ferroelectric and passivation and chamber	USPAT; US-PGPUB;	2004/03/19
			EPO; JPO;	17.31
			IBM TDB	
-	345	(ferroelectric and passivation and	USPĀT;	2004/03/19
		chamber) and electrode	US-PGPUB;	17:31
			EPO; JPO;	
_	236	((ferroelectric and passivation and	IBM_TDB USPAT;	2004/03/19
-	230	chamber) and electrode) and ("Al" or	US-PGPUB;	17:32
		aluminum) and ("Ti"or Titanium)	EPO; JPO;	
			IBM_TDB	
-	230	(((ferroelectric and passivation and	USPAT;	2004/03/19
		chamber) and electrode) and ("Al" or	US-PGPUB;	17:54
		aluminum) and ("Ti"or Titanium)) not	EPO; JPO; IBM TDB	
		chamber) and electrode) and ("Al" or	1511_105	
		aluminum) and ("Ti"or Titanium)) and		
		((("Al" or aluminum) and ("Ti"or		
		Titanium)) with passivation))		
-	16	((((ferroelectric and passivation and	USPAT;	2004/03/19
		chamber) and electrode) and ("Al" or aluminum) and ("Ti"or Titanium)) not	US-PGPUB; EPO; JPO;	17:56
		((((ferroelectric and passivation and	IBM TDB	
		chamber) and electrode) and ("Al" or		
		aluminum) and ("Ti"or Titanium)) and		
		((("Al" or aluminum) and ("Ti"or		
		Titanium)) with passivation))) and		
		(aluminum adj oxide) and (titanium adj oxide)		
_	23	(method or process) and (ferroelectric)	USPAT;	2004/03/20
		and electrode and chamber and ((Titanium	US-PGPUB;	18:34
		adj oxide) or "Ti.sub.2 O.sub.3") and	EPO; JPO;	
		((aluminum adj oxide) or "Al.sub.2	IBM_TDB	
_	4	O.sub.3") and passivation ((((titanium and aluminum and	USPAT;	2004/03/20
	"	passivation) and ferroelectric) not	US-PGPUB;	18:35
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
		ying-hong.in.)) and (chamber and (method	IBM_TDB	
		or process))) and ((top or upper) adj		
_	,	electrode)) and passivation.ab. (((((titanium and aluminum and	HCDAT.	2004/03/20
-	3	(((((titanium and aluminum and passivation) and ferroelectric) not	USPAT; US-PGPUB;	18:36
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
		ying-hong.in.)) and (chamber and (method	IBM_TDB	
		or process))) and ((top or upper) adj		
		electrode)) and passivation.clm.) not		
		<pre>(((((titanium and aluminum and passivation) and ferroelectric) not</pre>		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
1		ying-hong.in.)) and (chamber and (method		
		or process))) and ((top or upper) adj		
		electrode)) and passivation.ab.)	l	

-	6	((((titanium and aluminum and	USPAT;	2004/03/20
		passivation) and ferroelectric) not	US-PGPUB;	18:36
		(zhang-fengyan.in. hsu-sheng-teng.in.	EPO; JPO;	
		ying-hong.in.)) and (chamber and (method	IBM_TDB	,
		or process))) and ((top or upper) adj	į	
	_	electrode)) and passivation.clm.		
-	6	(((ferroelectric and passivation and	USPAT;	2004/03/20
		chamber) and electrode) and ("Al" or	US-PGPUB;	18:36
		aluminum) and ("Ti"or Titanium)) and	EPO; JPO;	
		((("Al" or aluminum) and ("Ti"or	IBM_TDB	
	7	Titanium)) with passivation)	USPAT;	2004/03/20
-	,	<pre>(((((ferroelectric and passivation and chamber) and electrode) and ("Al" or</pre>	US-PGPUB;	18:36
		aluminum) and ("Ti"or Titanium)) not	EPO; JPO;	10.30
		((((ferroelectric and passivation and	IBM TDB	
		chamber) and electrode) and ("Al" or	1011_100	
		aluminum) and ("Ti"or Titanium)) and		
		((("Al" or aluminum) and ("Ti"or		
		Titanium)) with passivation))) and		
		(aluminum adj oxide) and (titanium adj		
		oxide)) and (sputter\$4 near3 ((aluminum		
İ		or "Al") and (titanium or "Ti")))		
_	14	l	USPAT;	2004/03/20
		and electrode and chamber and ((Titanium	US-PGPUB;	18:37
		adj oxide) or "Ti.sub.2 O.sub.3") and	EPO; JPO;	
1		((aluminum adj oxide) or "Al.sub.2	IBM TDB	
		0.sub.3") and passivation) not	_	
		((((((titanium and aluminum and		
		passivation) and ferroelectric) not		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.)) and (chamber and (method		
		or process))) and ((top or upper) adj		
1		electrode)) and passivation.ab.)		
		(zhang-fengyan.in. hsu-sheng-teng.in.		
		ying-hong.in.) ((((((titanium and		
		aluminum and passivation) and		
		ferroelectric) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber and (method or process))) and		
		((top or upper) adj electrode)) and		
		passivation.clm.) not (((((titanium and		
		aluminum and passivation) and ferroelectric) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and		
		(chamber and (method or process))) and		
		((top or upper) adj electrode)) and		
		passivation.ab.)) (((((titanium and		
		aluminum and passivation) and		
		ferroelectric) not (zhang-fengyan.in.		
		hsu-sheng-teng.in. ying-hong.in.)) and	1	
		(chamber and (method or process))) and		
		((top or upper) adj electrode)) and		
		passivation.clm.) ((((ferroelectric and		
		passivation and chamber) and electrode)		
		and ("Al" or aluminum) and ("Ti"or		
		Titanium)) and ((("Al" or aluminum) and		
		("Ti"or Titanium)) with passivation))		
		((((((ferroelectric and passivation and		
		chamber) and electrode) and ("Al" or		
		aluminum) and ("Ti"or Titanium)) not		
į		((((ferroelectric and passivation and		
1		chamber) and electrode) and ("Al" or		
		aluminum) and ("Ti"or Titanium)) and		
		((("Al" or aluminum) and ("Ti"or		
		Titanium)) with passivation))) and		
		(aluminum adj oxide) and (titanium adj	1	1
		oxide)) and (sputter\$4 near3 ((aluminum	1	i